

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tsunehiro NISHI et al.

Confirmation No.: 4806

Serial No.: 10/073,223

Examiner:

Sin J. Lee

Filed:

February 13, 2002

Group Art Unit:

1752

Title:

POLYMER, RESIST COMPOSITION AND PATTERNING PROCESS

## **REPLY AFTER FINAL REJECTION**

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed April 12, 2004, kindly amend the above-identified application as follows.

Amendments and additions to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 17 of this paper.